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APPLICATION NO.	FILI	NG DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/899,784	07/05/2001		Dong-Su Kim	5000-1-212	2355
33942	7590	11/19/2003		EXAMINER	
CHA & RE		C	TOLEDO, FERNANDO L		
210 ROUTE 4 EAST PARAMUS, NJ 07652				ART UNIT	PAPER NUMBER
•				2823	
				DATE MAIL ED. 11/10/2009	,

DATE MAILED: 11/19/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)					
Office Action Community	09/899,784	KIM, DONG-SU					
Office Action Summary	Examin r	Art Unit					
The MAN INC DATE AND	Fernando Toledo	2823					
The MAILING DATE of this communication appears on the cover shet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	36(a). In no event, however, may a reply be ting within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	nely filed is will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).					
1) Responsive to communication(s) filed on 13 Au	<u>ugust 2003</u> .						
2a)⊠ This action is FINAL . 2b)☐ This	This action is FINAL . 2b) ☐ This action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims							
 4) Claim(s) 1,3-7,10,12-15,17 and 20-26 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) Claim(s) is/are allowed. 6) Claim(s) 1,3-7,10,12-15,17 and 21-26 is/are rejected. 7) Claim(s) 20 is/are objected to. 8) Claim(s) are subject to restriction and/or election requirement. 							
Application Papers	·						
9) The specification is objected to by the Examiner 10) The drawing(s) filed on 05 July 2001 is/are: a) Applicant may not request that any objection to the of Replacement drawing sheet(s) including the correction	☑ accepted or b)☐ objected to be drawing(s) be held in abeyance. See lon is required if the drawing(s) is obj	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).					
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. §§ 119 and 120 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 13) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78. a) The translation of the foreign language provisional application has been received. 14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.							
Attachment(s)							
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 	5) D Notice of Informal P	(PTO-413) Paper No(s) atent Application (PTO-152)					

DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 3 7, 10, 12, 13, 15, 17 and 21 26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Chan et al. (U. S. patent 6,306,706 B1) in view of Barnes et al. (U. S. patent 5,284,549).

In re claims 1, 10 and 21, Chan, in the U. S. patent 6,306,706 B1; figures 1 – 5 and related text, discloses selectively depositing an etch stop layer P1 on an etching area of a first silica layer formed on a semiconductor substrate (figure 5c); forming a second silica layer on the surface of the etch stop layer and the first silica layer (figure 5d); forming a mask patterned according to the shape of the etching area on the surface of the second silica layer (figure 5c); removing the second silica layer from the etching area using the mask by dry etching according to a predetermined vertical profile (figure 5e); removing the ctch stop layer by wet etching (figure 5e).

Chan does not show wherein the etch stop layer is one of gold, platinum or alumina.

However, Barnes in the U. S. patent 5,284,549 discloses wherein a ceramic layer (Al₂O₃) has a high etching ratio compared to SiO₂ (desirable ratio of 20:1) (column 3).

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It would have been obvious to one having ordinary skill in the art at the time the invention was made to form the etch stop layer of Chan with a ceramic material since, as taught by Barnes, it poses a high etching ratio compared to silica (ratio of 20:1).

- 3. In re claims 3, 12 and 22, Chan discloses forming the etch stop layer on the first silica layer; forming a photoresist layer on the etch stop layer; patterning the photoresist layer according to the shape of the etching area; and dry-etching the etch stop layer using the photoresist pattern (figures 5b and 5c).
- 4. In re claims 4, 13 and 23, Chan does not disclose wherein the etch stop layer is formed of one of metal and ceramic.

However, Barnes discloses wherein a ceramic layer (Al₂O₃) has a high etching ratio compared to SiO₂ (desirable ratio of 20:1) (column 3).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to form the etch stop layer of Chan with a ceramic material since, as taught by Barnes, it poses a high etching ratio compared to silica (ratio of 20:1).

- 5. In re claims 6, 15 and 25, Chan discloses wherein the first and second silica layers are formed by deposition (figure 5).
- 6. In re claims 7, 16 and 26, Chan does not disclose wherein the second silica layer is etched by RIE.

However Barnes discloses that RIE etching has a high selectivity to silica (column 1).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to etch the second silica layer by RIE in the invention of Chan, since as taught by Barnes, RIE has a high selectivity to silica.

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7. In re claim 17, Chan discloses wherein the second silica layer is removed according to a

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predetermined vertical profile (figure 5).

8. Claims 5, 14 and 24 is rejected under 35 U.S.C. 103(a) as being unpatentable over Chan

in view of Young et al. (U. S. patent 6,268,287 B1).

Chan discloses forming a poly-silicon layer on the second silica layer by sputtering;

forming a photoresist layer on the poly layer; patterning the photoresist layer according to the

shape of the etching area; and etching the poly layer using a photoresist pattern (figure 5).

Chan does not disclose wherein the mask layer is a metal layer.

However Young discloses that a mask layer formed with a metal layer will prevent

forming a polymer on the layer underneath the hard mask since it does not interact with the

photoresist (abstract).

It would have been obvious to one having ordinary skill in the art at the time the

invention was made to form the mask layer of Chan with metal, since, as taught by Young, it will

prevent formation of a polymer on the layer underneath the hard mask since it does not interact

with the photoresist.

Response to Arguments

9. Applicant contests that by adding the limitation of the objected claims alone would put

the application in condition for allowance. However, the objected claims would be allowable if

placed in independent form with all the limitations of the intervening claims.

10. In response to applicant's arguments, the recitation a planar light wave circuit (PLC) has

not been given patentable weight because the recitation occurs in the preamble. A preamble is

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generally not accorded any patentable weight where it merely recites the purpose of a process or

the intended use of a structure, and where the body of the claim does not depend on the preamble

for completeness but, instead, the process steps or structural limitations are able to stand alone.

See In re Hirao, 535 F.2d 67, 190 USPQ 15 (CCPA 1976) and Kropa v. Robie, 187 F.2d 150,

152, 88 USPQ 478, 481 (CCPA 1951).

Claim Objections

11. Claim 20 is objected to as being dependent upon a rejected base claim, but would be

allowable if rewritten in independent form including all of the limitations of the base claim and

any intervening claims.

Conclusion

12. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time

policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE

MONTHS from the mailing date of this action. In the event a first reply is filed within TWO

MONTHS of the mailing date of this final action and the advisory action is not mailed until after

the end of the THREE-MONTH shortened statutory period, then the shortened statutory period

will expire on the date the advisory action is mailed, and any extension fee pursuant to 37

CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event,

however, will the statutory period for reply expire later than SIX MONTHS from the mailing

date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fernando Toledo whose telephone number is 703-305-0567. The examiner can normally be reached on Mon-Fri 8am to 4pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 703-306-2794. The fax phone number for the organization where this application or proceeding is assigned is 703-308-7382.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

George Fourson Primary Examiner Art Unit 2823

FToledo